

Electronic Patent Application Fee Transmittal

Application Number:	10516457
Filing Date:	03-Dec-2004
Title of Invention:	Heating jacket for plasma etching reactor, and etching method using same
First Named Inventor/Applicant Name:	Michel Puech
Filer:	David J. Cushing
Attorney Docket Number:	Q84448

Filed as Large Entity

U.S. National Stage under 35 USC 371 Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Notice of appeal	1401	1	510	510
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Post-Allowance-and-Post-Issuance:

Extension-of-Time:

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 2 months with \$0 paid	1252	1	460	460
Miscellaneous:				
Total in USD (\$)				970